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App	olication No.	Applicant(s)
10/	716,439	HANSEN, STEVEN GEORGE
Notice of Allowability Exa	miner	Art Unit
Al	n A. Mathews	2851
The MAILING DATE of this communication appears of All claims being allowable, PROSECUTION ON THE MERITS IS (OR herewith (or previously mailed), a Notice of Allowance (PTOL-85) or ot NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHT of the Office or upon petition by the applicant. See 37 CFR 1.313 and	REMAINS) CLOSED in this ap her appropriate communicatio S . This application is subject	pplication. If not included on will be mailed in due course. THIS
1. This communication is responsive to		
2. ☑ The allowed claim(s) is/are <u>1-25</u> .		
3. $igotimes$ The drawings filed on <u>20 November 2003</u> are accepted by the E	xaminer.	
4. Acknowledgment is made of a claim for foreign priority under 3 a) All b) Some* c) None of the:		
 Certified copies of the priority documents have been Certified copies of the priority documents have been 		
3. Copies of the certified copies of the priority documents have been	· · · -	· · · · · · · · · · · · · · · · · · ·
International Bureau (PCT Rule 17.2(a)).	nta nave been received in the	The stage application from the
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of thi noted below. Failure to timely comply will result in ABANDONMENT THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		y complying with the requirements
 A SUBSTITUTE OATH OR DECLARATION must be submitted. INFORMAL PATENT APPLICATION (PTO-152) which gives rea 		
6. CORRECTED DRAWINGS (as "replacement sheets") must be	submitted.	
(a) \square including changes required by the Notice of Draftsperson's	Patent Drawing Review (PTC)-948) attached
1) hereto or 2) to Paper No./Mail Date		·
(b) including changes required by the attached Examiner's Ame Paper No./Mail Date	endment / Comment or in the	Office action of
Identifying indicia such as the application number (see 37 CFR 1.84(c) each sheet. Replacement sheet(s) should be labeled as such in the he		
 DEPOSIT OF and/or INFORMATION about the deposit of attached Examiner's comment regarding REQUIREMENT FOR 		
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5. Notice of Informal	Patent Application (PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summar	y (PTO-413),
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date 11/20/03; 2/20/04 · 5/10/04 · 8/27/	Paper No./Mail Da 7. Examiner's Amend	ate
4. ☐ Examiner's Comment Regarding Requirement for Deposit		nent of Reasons for Allowance
of Biological Material	9.	41
	a	Clan a Mathews
	A	Alan A. Mathews rimary Examiner
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U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) Application/Control Number: 10/716,439

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REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

The prior art does not disclose or suggest a method for optimizing an illumination condition of a lithographic apparatus by computer simulation using isofocal compensation; selecting a simulation model, selecting a grid of source points in a pupil plane of the illuminator; calculating separate responses for individual source points, each of the responses representing a result of a single or series of simulations using the simulation model; calculating a metric representing variation of the separate responses for individual source points with defocus; and adjusting an illumination arrangement based on analysis of the metric in combination with all the other steps recited in independent claim 1.

The prior art does not disclose or suggest a processor to define a lithographic pattern to be printed on the substrate, to selected a grid of source points in a pupil plane of the illumination system, to calculate separate responses for individual source points, each of the responses representing a result of a single or series of simulation using a simulation model, to calculate a metric representing variation of the separate responses for individual source points with defocus; and to calculate an optimized illumination arrangement based on analysis of the metric; and a selectable variable beam controller that is adapted to modify a cross sectional intensity distribution in the projection beam exiting the illumination system in accordance with the

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optimized illumination arrangement calculated by the processor in combination with all the other elements recited in independent claim 22.

The prior art does not disclose or suggest a machine readable medium with executable instructions for optimizing an illumination condition of an illuminator using isofocal compensation comprising: selecting a grid of source points in a pupil plane of the illuminator; calculating separate responses for individual source points, each of the responses representing a result of a single or series of simulations using the simulation model; calculating a metric representing variation of the separate responses for individual source points with defocus; and adjusting an illumination arrangement based on analysis of the metric in combination with all the other elements and executable instructions recited in independent claim 23.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alan A. Mathews whose telephone number is (571) 272-2123.

The examiner can normally be reached on Monday through Friday from 8:00 AM to 4:30 PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on (571) 272-2258. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Alan A. Mathews Primary Examiner

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